Application/Control No.		Applicant(s)/Patent under Reexamination	r /*
10/70	07,277	CHEN ET AL.	6
Exam	niner	Art Unit	
Alan	S. Chen	2182	

SEARCHED					
Class	Subclass	Date	Examiner		
710	8	5/2/2006	ASC		
	20				
	22				
	62				
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713	1				
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
see sear history	ch printouts				

SEARCH NO (INCLUDING SEARCE		·)
	DATE	EXMR
(EAST) USPAT; USPGPUB; EPO; JPO; IBM_TDB; DERWENT PLUS; Inventor Search	5/2/2006	ASC
Tanh Nguyen	5/2/2006	ASC